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## Graphene based Electronic Devices

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Deadline for manuscript  
submissions:

**closed (31 October 2020)**

### Message from the Guest Editor

Graphene has gained interest as a promising material in future electronic devices due its high conductance and potential for the flexible modification of its electronic and structural properties. In this Special Issue of *Micromachines*, researchers and developers are invited to submit manuscripts for the Special Issue “Graphene-Based Electronic Devices”, where we wish to focus on advancements in the fabrication and characterization of different electronic structures. Articles, short communications, and review articles are all welcome that cover a broad range of possible topics, including fabrication and characterization of graphene and graphene oxide thin films; graphene-based batteries and fuel cells; photovoltaics; graphene for flexible electronics and display; and other new applications and circuits based on graphene and graphene oxide. All submissions will be reviewed in accordance with the normal procedures of *Micromachines*.



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# Special Issue



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## Message from the Editor-in-Chief

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